

Notice of References Cited	Application/Control No. 10/596,755		Applicant(s)/Patent Under Reexamination OKAMOTO ET AL.	
	Examiner HUI CHIN		Art Unit 4131	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,350,807	02-2002	Blok et al.	524/493
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	O	JP 2000044633 A	02-2000	Japan	NAKAMURA et al.	C08F136/06
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NON-PATENT DOCUMENTS

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	U	Translation of JP56109205, August, 1981.
	V	Translation of JP 2000044633, February, 2000.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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